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ISSN: 2349-5162 | ESTD Year: 2014 | Monthly Issue



## JOURNAL OF EMERGING TECHNOLOGIES AND INNOVATIVE RESEARCH (JETIR)

An International Scholarly Open Access, Peer-reviewed, Refereed Journal

Ref No: JETIR / Vol 10 / Issue 5 / A33

**Confirmation Letter** 

To,

**Shekhar Pawar** 

: Volume 10 | Issue 5 | 2023-05-25 Published in



Subject: Publication of paper at International Journal of Emerging Technologies and Innovative Research.

Dear Author,

With Greetings we are informing you that your paper has been successfully published in the International Journal of Emerging Technologies and Innovative Research (ISSN: 2349-5162). Following are the details regarding the published paper.

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DOI

Published in : Volume 10 | Issue 5 | 2023-05-25

Publication Date: 2023-05-25 Page No : k253-k257

Published URL: http://www.jetir.org/view?paper=JETIR2305A33

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Thank you very much for publishing your article in JETIR. We would appreciate if you continue your support and keep sharing your knowledge by writing for our journal JETIR.

















International Journal of Emerging Technologies and Innovative Research (ISSN: 2349-5162)

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